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Atty.Docket No.
0756-1299

Serial No. (TO BE
ASSIGNED)
Based on S.N. ~~88-1208-1220~~

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant
Hongyong ZHANG et al.

Filing Date
June 5, 1995

Group ~~2508~~ 2823

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner

Date Considered

Examiner CRADONSKY Date Considered 11/1/12

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Form PTO-1449
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U.S. Department of Commerce
Patent and Trademark Office

Attorney Docket No. 0756-1641

Serial No. 08/811,742

Applicant: Hongyong ZHANG et al.

INFORMATION DISCLOSURE STATEMENT

Filing Date: March 6, 1997

Group: 2823

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
SAH	5,075,259	12/24/91	Moran			
SAH	3,783,049	01/01/74	Sandera			
SAH	5,300,187	04/05/94	Lesk et al			
SAH	5,244,819	09/14/93	Yue			
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SAH	5,225,355	07/06/93	Sugino et al			
SAH	4,231,809	11/04/80	Schmidt			
SAH	RE 28,386	04/08/75	Heiman et al			
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SAH	5,773,327	06/30/98	Yamazaki et al			

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SAH	Wolf, "Silicon Processing for the VLSI ERA Volume 2: Process Integration", Lattice Press, June 1990, p. 144-146
SAH	Fortuna et al., "In Situ Study of Ion Beam Induced Si Crystallization from a Silicide Interface", Applied Surface Science, Vol. 73, 1993, pp. 264-267
SAH	Lee et al., "Pd Induced Lateral Crystallization of Amorphous Si Thin Films", Appl. Phys. Lett., Vol. 66, No. 13, March 27, 1995, pp. 1671-1673
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SAH	Gong et al., "Thermodynamic Investigations of Solid-State Si-Metal Interactions. II. General Analysis of Si-Metal Binary Systems", J. Appl. Phys., Vol. 68, No. 9, November 1, 1990, pp. 4542-4549
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SAH	Liu et al., "Polycrystalline Silicon Thin Film Transistors on Corning 7059 Glass Substrates using Short Time, low-Temperature Processing", Appl. Phys. Lett., Vol. 62, No. 20, May 17, 1993, pp. 2554-2556
SAH	Liu et al., "Selective Area Crystallization of Amorphous Silicon Films by Low-Temperature Rapid Thermal Annealing", Appl. Phys. Lett., Vol. 55, No. 7, August 14, 1989, pp. 660-662
SAH	Caune et al., "Combined CW Laser and Furnace Annealing of Amorphous Si and Ge in Contact with Some Metals", Applied Surface Science, Vol. 36, 1989, pp. 567-604

Examiner

Date Considered

7/28/99

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Substitute for form 1449A/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	08/811,742
		Filing Date	March 6, 1997
		First Named Inventor	Hongyong Zhang et al.
		Group Art Unit	2823
		Examiner Name	Scott A. Brainton <i>Khiem D. Nguyen</i>
Sheet 1 of 1	Attorney Docket Number	740756-1641	

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ³ (if known)			
<i>K.N.</i>		5,814,540		Takemura et al.	09-29-1998	
<i>K.N.</i>		5,077,233		Mukai	12-31-1991	

FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Office ³	Number ⁴				
<i>K.N.</i>			EP 0 178 447	B1 Mukai	04-23-1986		Full

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Examiner Signature	<i>Khiem D. Nguyen</i>	Date Considered	11/11/02
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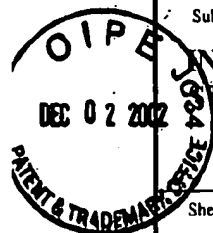
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		Filing Date	March 6, 1997
		First Named Inventor	Hongyong ZHANG et al.
		Art Unit	2823
		Examiner Name	Khiem D. Nguyen
		Attorney Docket Number	740756-1641
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Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		Country Code ³	Number ⁴ (if known)				
K.N.		JP	04-022120	01/27/1992	Masabumi Kunii		AB

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Examiner Signature	<i>Khiem D. Nguyen</i>	Date Considered	05/15/03
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		Number - Kind Code ³ (if known)			
K.N.		US-6.486.497	11-26-2002	Misawa et al.	
		US-			
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FOREIGN PATENT DOCUMENTS						
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		Country Code ⁵ Number ⁶ Kind Code ³ (if known)				
K.N.		EP 0 342 925 A2	11-23-1989	Misawa et al.		Full

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K.N.		CHINESE OFFICE ACTION DATED SEPTEMBER 5, 2003	

Examiner Signature	<i>Khiem D. Nguyen</i>	Date Considered	04/26/04
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